



EXPRESS MAIL NO. EV 678997660 US

IDS Form PTO/SB/08: Substituted for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Application Number	09/903,081
				Filing Date	July 10, 2001
				First Named Inventor	DEMARAY, Richard E.
				Art Unit	1731
				Examiner Name	HOFFMAN, John M.
Sheet	1	of	1	Attorney Docket Number	9140.0014-00

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		5,478,456	12-26-1995	Humpal et al.	
		6,846,765 B2	01-25-2005	Imamura et al.	

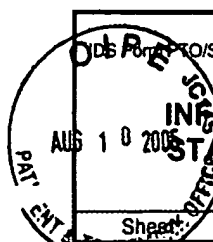
Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				

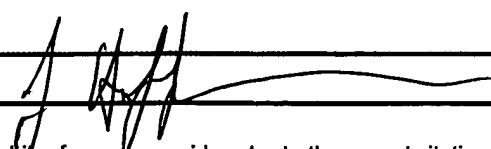
NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
		DOREY, R.A., "Low temperature micromoulding of functional ceramic devices," Grant summary for GB/S84156/01 for the UK Engineering and Physical Sciences Research Council, 2 pages (2004).	
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		Office Action issued on August 4, 2005, in U.S. Serial No. 10/101,863 (Attorney Docket No. 09140-0016-00).	
		Office Action issued on August 8, 2005 in U.S. Serial No. 10/101,341 (Attorney Docket No. 09140-0017-00).	

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		US 2005/0006768 A1	01-13-2005	Narasimhan et al.	
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


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		EP 1 189 080 A2	03/20/2002	Agere Systems Optoelectronics Guardian Corporation		
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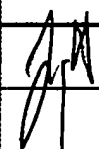
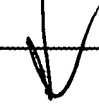
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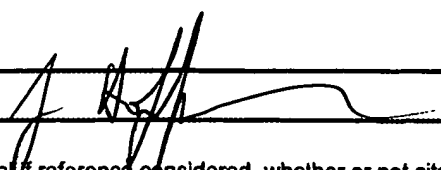
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		Response to Office Action filed on March 3, 2004 in U.S. Serial No. 10/101,492 (Attorney Docket No. 09140-0015-00).

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		Written Opinion issued on October 11, 2004 in PCT/US2004/005531 (Attorney Docket No. 09140-0030-00304)
		Office Action issued March 24, 2005 in U.S. Application No. 10/851,542 (Attorney Docket No. 09140.0033-00).

Examiner Signature		Date Considered	11-21-05
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.